

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	38	(substrate or wafer or disc or disk) and (clean\$3 or scrub\$4) and edge and brush and roller	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/27 10:00
L3	0	(substrate or wafer or disc or disk) and (clean\$3 or scrub\$4) and roller and vertical2	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/27 10:01
L4	2249	(substrate or wafer or disc or disk) and (clean\$3 or scrub\$4) and roller	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/27 10:01
L5	357	l4 and brush	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/27 10:01
L6	153	l5 and (edge or side or peripher\$2)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/12/27 10:02